PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Terunao HANAOKA and Kenji WADA

Application No.: Divisional of Application No.

09/870,710 filed June 1, 2001

Filed: February 2, 2004

Docket No.: 109690.01

For:

SEMICONDUCTOR DEVICE, METHOD OF FABRICATING THE SAME, STACK-

TYPE SEMICONDUCTOR DEVICE, CIRCUIT BOARD AND ELECTRONIC

INSTRUMENT

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

 \boxtimes This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required. 2. The references were cited by or submitted to the Office in parent application No. 09/870,710, filed June 1, 2001, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,

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Date: February 2, 2004

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
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Sheet	1	of 1	

Form PTO-1449 US Dept. of Commerce (REV. 8-83) PATENT & TRADEMARK OFFICE			ATTY DOCKET NO. 109690.01		APPLICATION NO. Divisional of Application No. 09/870,710			
INFORM	MATION DISCLOSURE STATEMENT							
(Use several sheets if necessary)			APPLICANT(S) Terunao HANAOKA and Kenji WADA					
			FILING DATE February 2, 2004		GROUP			
	U.S.	PATE	ENT DOCU	MENTS				
EXAMINER INITIAL			DATE	NAME		CLASS	SUB CLASS	
			1987	Vijan				
			1999	Nishi et al.				
			2002	Hikita et al.				
	6,225651 - B1	05/2001 04/2001		Billon		257	200	
	6,222,276			Bertin et al.		257	778	
	6,150,188 - A	11/2000		Geusic et al.		438	31	
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	4,984,358 - A		1991	Nelson		438	109	
	FOREIG	GN P	ATENT DO	CUMENTS				
	DOCUMENT NUMBER		DATE	COUNTRY		CLASS	SUB CLASS	
	JP A5-206286	08/	1993 Japan					
	JP A 8-83881		03/1996 Japan					
	JP A 10-223833	08/1		Japan				
JP-52065666-A 9-321175		05/	1997	Japan				
		12/1997		Japan				
	OTHER DOCUMENTS (In	cludi	ng Author,	Title, Date, Pertinent Pages, e	tc.)			
						,		
EXAMINER				D	DATE CONSIDERED			
Examiner: Ir	nitial if citation considered, whether or not conformance and not considered. Include conv	itatio	on is in cor	nformance with M.P.E.P. 609	; draw line	through cita	tion if not in	

Date: February 2, 2004